

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 16, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG669476540

LABORATORY GROWN DIAMOND

PRINCESS CUT

7.38 X 7.15 X 4.79 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.31 CARATS

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

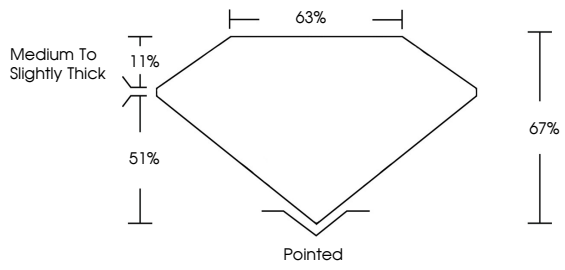
NONE

Inscription(s)

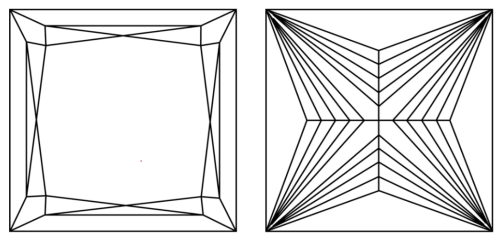
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



PROPORTIONS



CLARITY CHARACTERISTICS




KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

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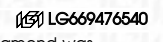
EXCELLENT

EXCELLENT

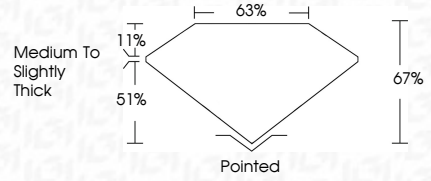
NONE

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PROPORTIONS



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VS<sup>1-2</sup>

VS<sup>1-2</sup>

SI<sup>1-2</sup>

I<sup>1-3</sup>

Internally Flawless

Very Very Slightly Included



Very Slightly Included

Slightly Included

Included

IGI Logo

IGI



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December 16, 2024

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PRINCESS CUT

7.38 X 7.15 X 4.79 MM

2.31 CARATS

D

VVS 1

67%

63%


Medium to Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE



Carat Weight

Color Grade

Clarity Grade

Depth

Table

Graile

Culet

Polish

Symmetry

Fluorescence

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